

APPLICATION DATA SHEET

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Stylesheet Version: 1.0

Attorney Docket Number: 740756-2447

Publication Filing Type:

new-utility

Application Type:

utility

Title of Invention:

INSULATING FILM AND METHOD OF PRODUCING
SEMICONDUCTOR DEVICE

Suggested Representative Figure:

Fig. 1A

Customer Number Correspondence Address:

22204

22204

Continuity Data:

This application is a division of 09/466,828 1999-12-20 Pending

This application is a continuation of 09/190,828 1998-11-12 Issued

This application is a division of 08/734,127 1996-10-21 Issued

This application is a continuation in part of 08/455,574 1995-05-31 Abandoned

This application is a division of 08/198,054 1994-02-18 Abandoned

Foreign Priority:

5-55236

JP

1993-02-19

Priority Claimed

Assignee (Publish): SEMICONDUCTOR ENERGY LABORATORY CO., LTD.

398, Hase

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